

# **JPO / U.S. Bar Liaison Council Meeting**

**January 16, 2009  
Special Conference Room, 16F  
Japan Patent Office**

## **Agenda**

### **Morning Session**

(Chaired by Mr. Masayuki Koyanagi, JPO)

- 10:00 – 10:15    Opening**
- Opening address by **Mr. Koichi Minami, Deputy Commissioner, JPO**
  - Opening address by **Mr. Jeffrey Navon, the U.S. Bar**
  - Introduction of participants
- 10:15 – 10:35    Rule change proposals in the U.S.**  
(Presentation by the U.S. Bar, **Mr. Samson Helfgott**)  
Continuation/claim limitation, IDS requirements, Markush claims,  
ex parte appeal, etc.
- 10:35 – 11:05    Inventive step/obviousness after KSR**  
(Presentation by the U.S. Bar, **Mr. John Osha**)
- 11:05 – 11:45    Measures to reduce backlogs in the U.S./Japan**  
(Presentation by the U.S. Bar/JPO,  
**Mr. Samson Helfgott / Mr. Matsuo Nonaka**)
- 11:45 – 12:55    Lunch at the JPO**

## **Afternoon Session**

(Chaired by Mr. Shintaro Takahara, JPO)

- 12:55 – 13:15 Measures to monitor the quality of examination**  
(Presentation by the JPO, Mr. Satoshi Hattori)
- 13:15 – 13:40 Programs to improve the quality of PCT search**  
(Presentation by the JPO, Mr. Hiroshi Kawamata)
- 13:40 – 14:00 Bilski case and its impact**  
(Presentation by the U.S. Bar, Mr. Sam Petuchowski)
- 14:00 – 14:20 Outlook of U.S. IP policy under the new administration**  
(Presentation by the U.S. Bar, Mr. John Pegram)  
Incl. future deliberation of Patent Reform Act
- 14:20 – 14:30 Break**
- 14:30 – 15:00 Development of global work-sharing (JP-FIRST, PPH)**  
(Presentation by the JPO, Mr. Hiroki Uejima)
- 15:00 – 15:50 Requests concerning Japanese laws and practices**  
(Presentation by the U.S. Bar, Mr. Kuniyuki Akiyama, et al.)
- Specification of identical part(s) in cited document
  - Extension of the period of divisional application filing
  - Provision of Search Report before substantive examination
  - Extension of the patent term
  - Possibilities for introduction of "License of Right" system
  - Annual fee matters
  - Patent decision rate of the JPO.
  - Reduction of the examination fee
  - Piecemeal Prosecution (Mr. Samson Helfgott)
- 15:50 – 16:00 Closing**

## ATTENDEES

### Japanese Patent Office Side:

Koichi Minami	Deputy Commissioner
Masayuki Koyanagi	Director, International Affairs Division
Akiteru Tamura	Director, Examination Standards Office
Satoshi Hattori	Director, Quality Management Office
Shintaro Takahara	Director, Multilateral Policy Office
Narumi Hosokawa	Deputy Director, General Affairs Division
Matsuo Nonaka	Deputy Director, Policy Planning and Research Section
Tsuyoshi Isozumi	Deputy Director, International Affairs Division
Hiroshi Kawamata	Deputy Director, International Affairs Division
Takuya Tanabu	Deputy Director, Examination Standards Office
Kenji Shimada	Deputy Director, Policy Planning and Research Division
Masayuki Hoshino	Deputy Director, Examination Standards Office
Hiroyuki Honda	Deputy Director, Quality Management Office
Kenji Saito	Deputy Director, International Affairs Division
Hiroki Uejima	Assistant Director, Patent Examination Policy Planning Office
Hirokazu Muta	Assistant Director, International Affairs Division